



# In-Situ Monitoring/Lifetime Prognostication of Critical System Components Utilizing Unintended Emission Analysis Techniques

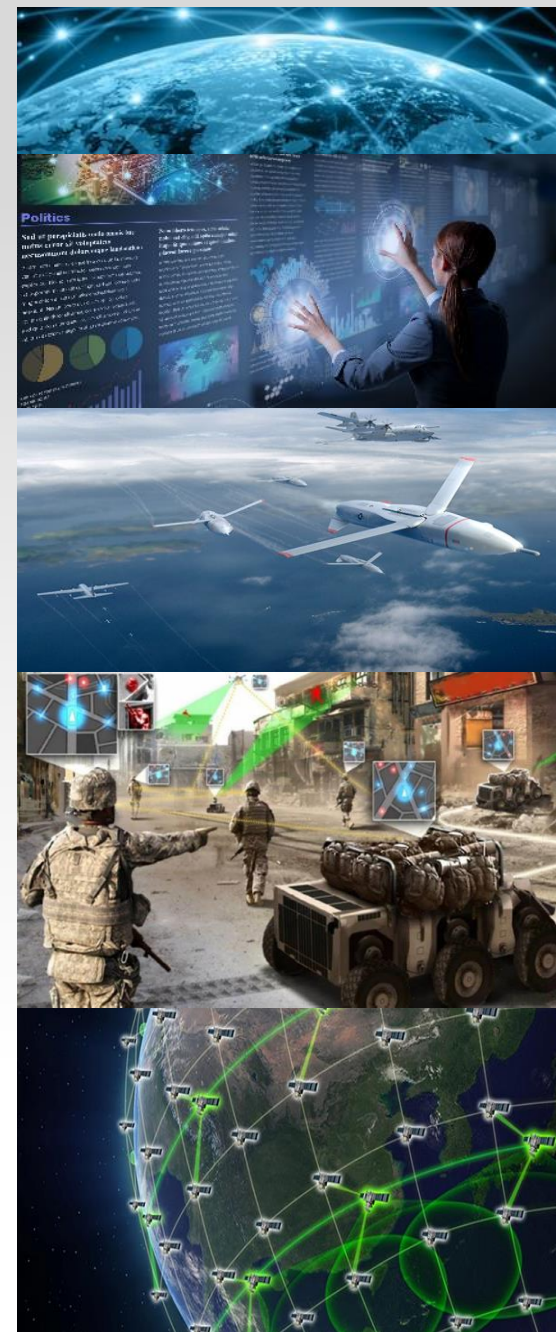
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# Traditional Reliability/Lifetime Prognostication



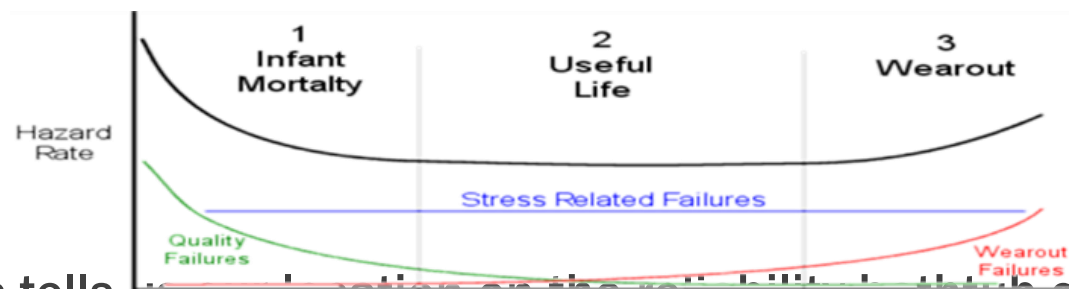
$$AF = \left(\frac{V_A}{V_R}\right)^n \text{EXP} \left( - \left(\frac{E_A}{k_B}\right) \left(\frac{1}{T_F} - \frac{1}{T_I}\right) \right)$$

- **Issue 1: The above equation is applied indiscriminately to virtually every active and passive device to quantify reliability**
  - Discrete components to integrated circuits: no distinction is made for device architectures or even the materials used in device fabrication
- **Issue 2: Extremely tenuous link to physical reality ( $E_A$  and  $n$ )**
  - $E_A$  is formally defined as the minimum kinetic energy required for molecular collisions to result in a chemical reaction
  - For reliability calculations  $E_A$  is redefined as the energy required to activate latent defects in the material—are these concepts equivalent??
  - For reliability calculations  $E_A$  is treated as a constant. Yet, in chemical reactions, there is a much greater probability that molecules will collide and initiate a reaction due to thermal agitation at higher temperatures. This implies  $E_A$  has some degree of temperature dependence
  - Values for  $E_A$  used in reliability calculations are subjective estimates
    - Usually,  $E_A$  is given as a range of values...and the above equation is sensitive to both  $E_A$  and  $n$  (often not defined at all and typically taken to be unity)
  - Manufacturers acknowledge these issues by de-rating calculated lifetimes using these methods, often by an order of magnitude



# Unintended Emission Analysis

- **Main Idea: All active electronics generate unintended emissions**
  - Examples: power fluctuations, electromagnetic fields, thermal profiles
  - Passive electronics can also be induced to yield emission data
  - Very strong physical basis: emissions are characteristic of device architecture and fabrication materials
- **Emission Data can be leveraged to quantify degradation**
  - Causal relationship between component condition emission spectra
  - Devices in various stages of degradation have unique emission spectra
- **Comparative analysis of known good to degraded components**
- **Analysis of emission data and associated distributions can be used to prognosticate Remaining Useful Life (RUL)**



- **Emission analysis tells us our location on the reliability bathtub curve-Traditional reliability approach does not provide this information**



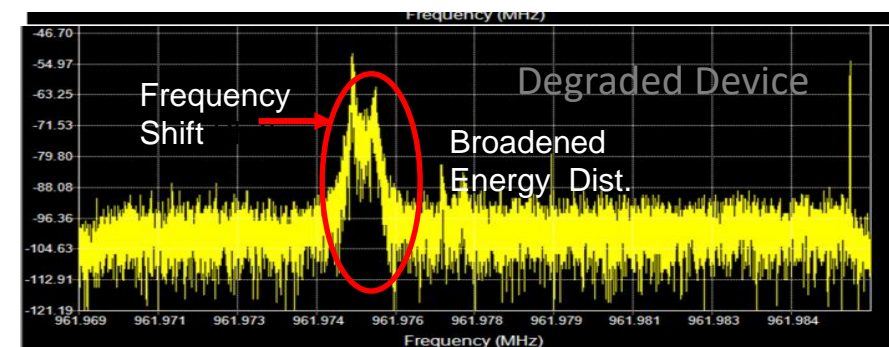
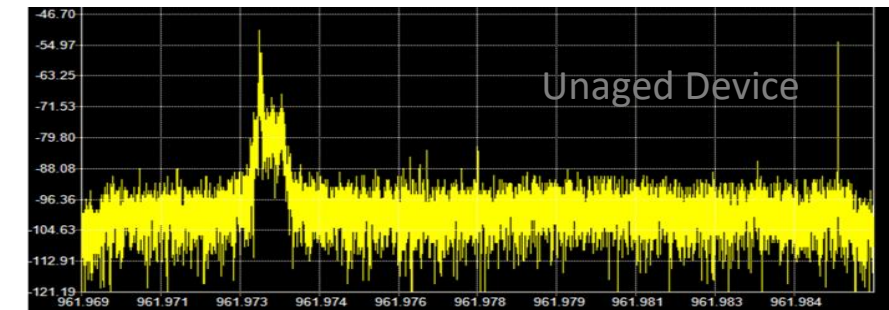
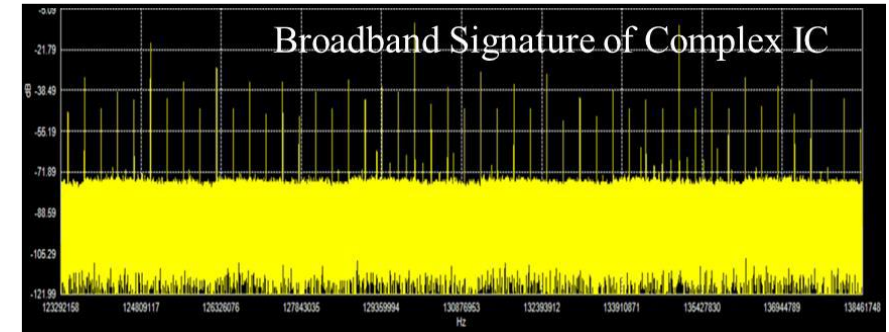
# Analytic Signals & Transforms

- **Analytic Signal: A complex-valued function with no negative frequency component**
  - Created from emission data- retains strong link to physical device
- **General form:**
  - $Y(t) = y(t) + ih(t)$
- **Analytic signals are created by application of mathematical transforms to the sampled data**
  - Common transforms include the Fast Fourier Transform (FFT) and the Hilbert Transform
- **Why transform the sampled data?**
  - Very subtle changes in the real-valued signal are easily identified in the transform domain
  - Transformed signal contains more dynamic information than original measured signal
    - Amplitude
    - Phase
    - Instantaneous frequency....many others
- **Analytic signals form the basis of an algorithmic approach to monitoring device degradation and lifetime prognostication**



# EM Signature Analysis Data Acquisition

- Emission data detection with high acuity RF sensor
  - Collection of broadband data
- Extended Frequency range
  - Billions of data points per part
  - ~ 1 hour to collect data
- Target parameters of interest:
  - Frequency shifts of specific peaks
  - Harmonic content
  - Energy distribution
  - Time varying shifts in data
- Extremely sensitive technique
  - Extremely close to theoretical limit of -173 dBm
  - Can detect process variation, code changes, packaging stress...and aging



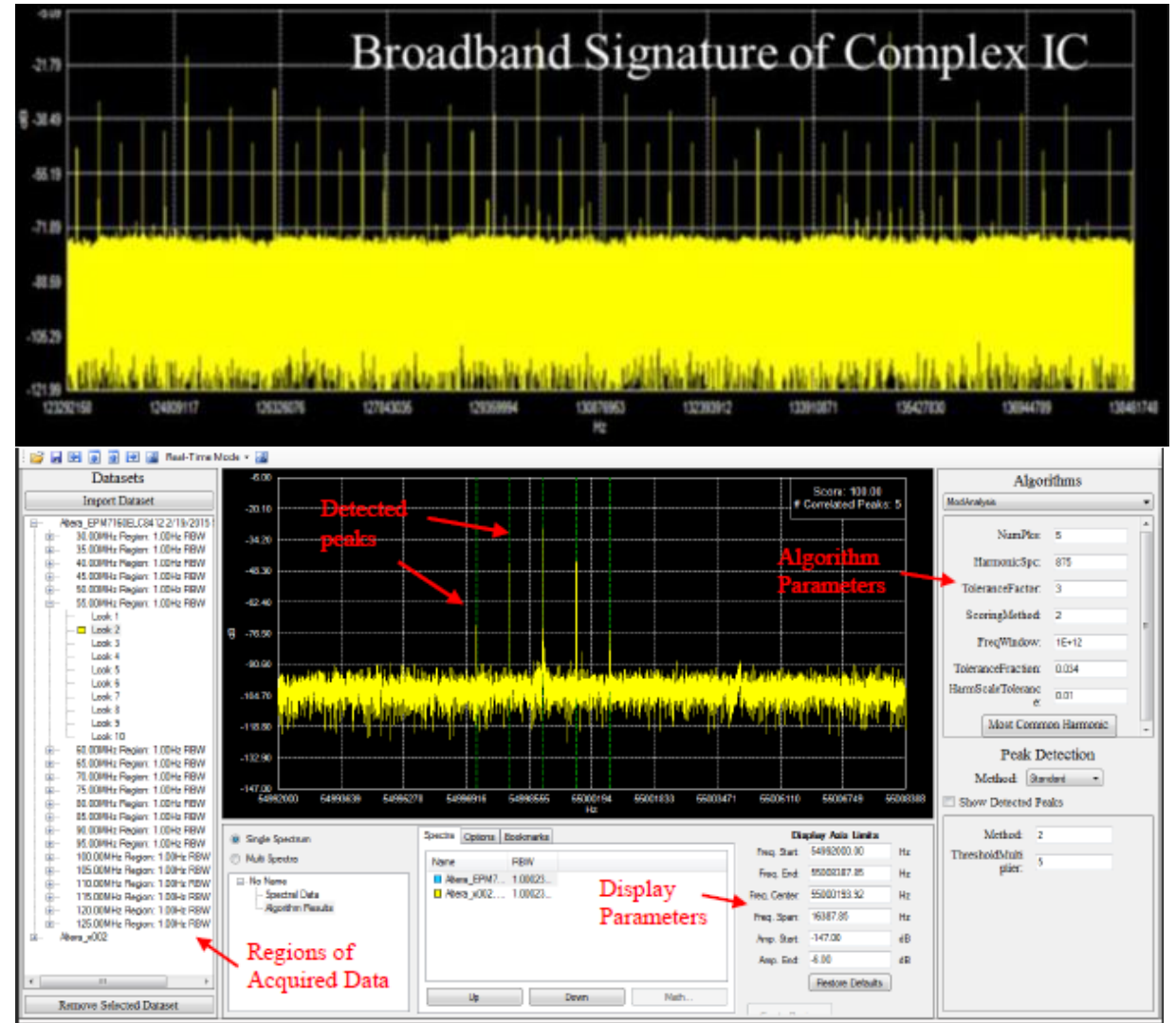
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# EM Signature Analysis Emulation Software



- Emulation software used to capture time-varying content
  - Certain broadband signature metrics are time dependent
  - Provides a platform for detailed signature assessment
- Can also be utilized for comparative assessments of multiple data sets

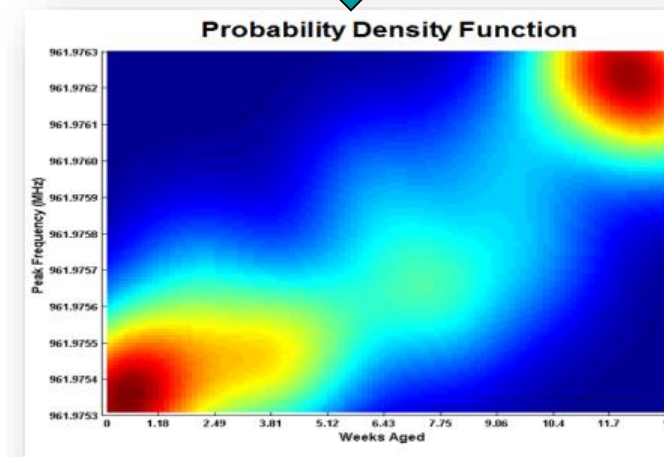
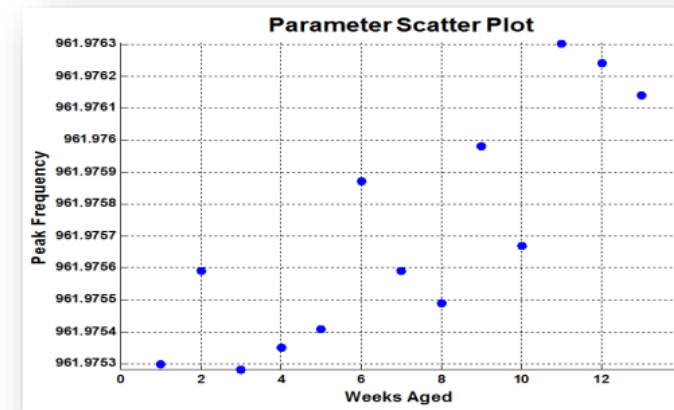


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# Remaining Useful Life (RUL) Prognostication

- RUL prognostication performed using Bayesian statistics
- Utilized functional relationships between signature metric values and device age
  - Function parameter sets each have a calculated likelihood based on how well they fit measured data
  - RUL predicted by each parameter set is weighted by its likelihood
  - Combination of weighted RULs for all parameter sets provides a RUL predicted by each metric
  - Combination of RUL predictions for all metrics increases accuracy and lowers uncertainty
- Bayesian approach leverages previous measurement history on the DUT and other similar devices to increase accuracy

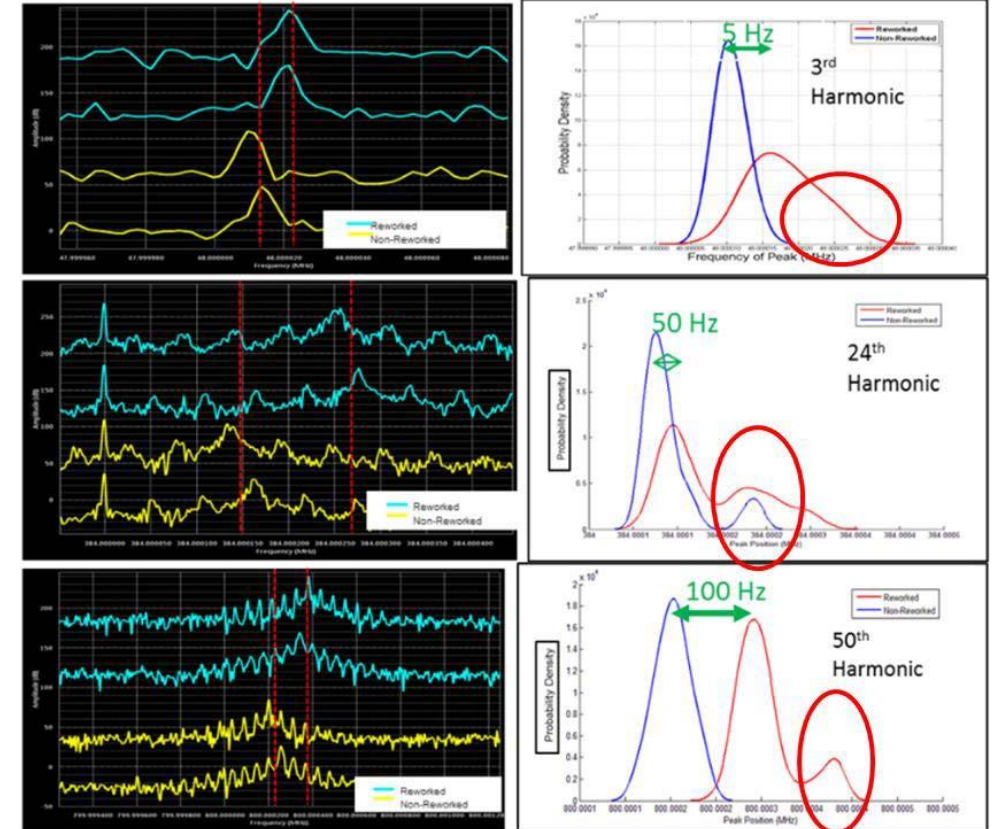




# Probability Distribution Analysis for Health/Lifetime Monitoring



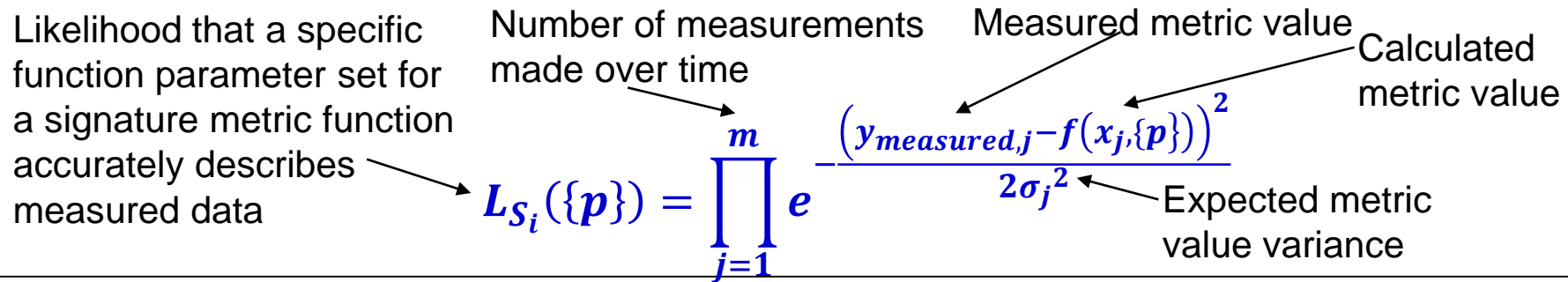
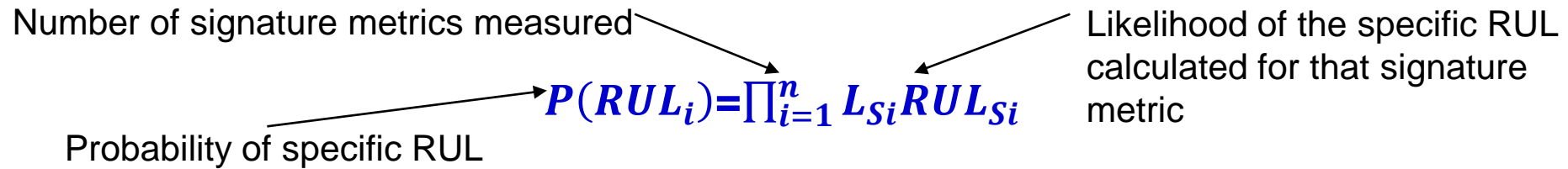
- Probability distribution functions (PDF) created for each signature metric
- Multiple metrics utilized to determine lifetime/quantify degradation
- Comparative analysis with known good sample generally correlates changes to circuit condition
  - Shift in mean value
  - Broadening of distribution
  - Bimodal behavior
- Algorithmic methodology and high degree of integration allows real time monitoring of PDFs associated with component-of-interest







# Prognostication Mathematics



Probability of an RUL value determined by multiplying PDFs for each signature metric, where each PDF is calculated based upon measured signature metric values

$$P(RUL_i | \{S\}) = \frac{\prod_{j=1}^m P(S_j | RUL_i)}{\sum_{i=1}^n \left( \prod_{j=1}^m P(S_j | RUL_i) \right)}$$

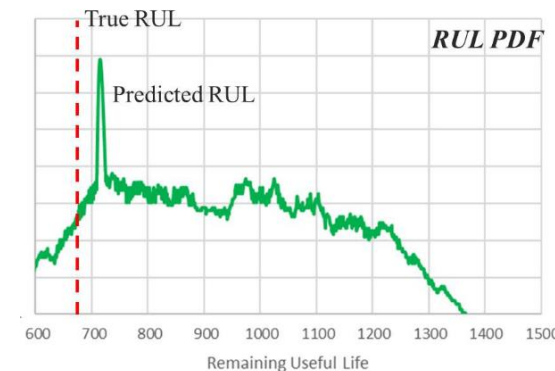
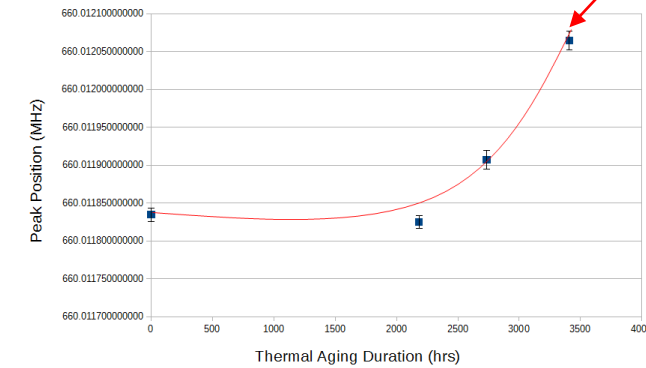
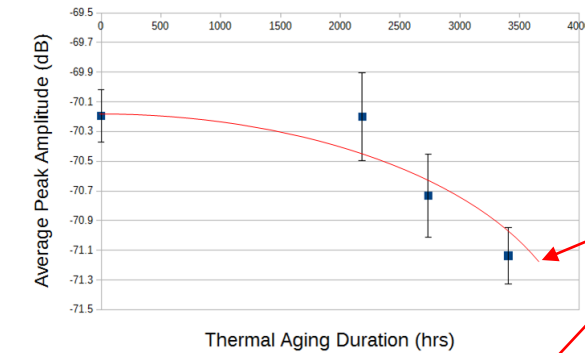
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# Sample RUL of MSP 430 Embedded Flash



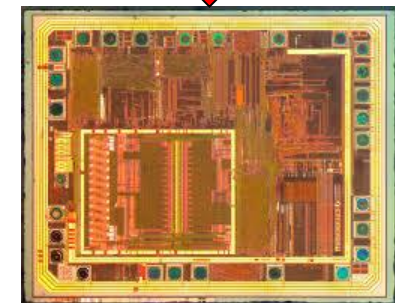
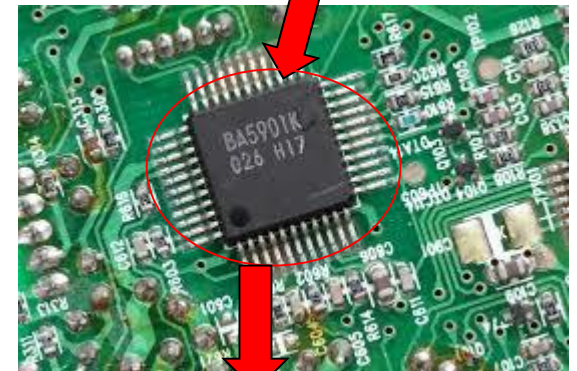
- One thermally aged devices at 150°C for 2736 hrs
- Two metrics utilized in sample calculation (Shown at Right)
  - Average peak amplitude (dB)
  - Peak Position (MHz)
  - Error bars represent one stddev
- End of life taken to be device with 3408 hrs at 150°C
  - Enabled comparison of predicted result to known sample
- Result: Predicted RUL deviation from known RUL by 49 hrs (7.2%)
  - Prediction would be more precise and accurate if more metrics were utilized (in practice multiple metrics are utilized)



3408 hrs

# In-Situ Monitoring: Scalability

- Techniques discussed have a broad application space:
  - Circuit Card Assembly (CCA) level: multiple components
  - Passive and active component level
  - Design IP level: specific embedded, on-die components
- Techniques described are technology agnostic:
  - More complex devices yield more emission data
  - Localization of component on CCA possible due to unique emission spectra occurring in different bandwidths for each device
  - Simple devices such as passives are more difficult, due to less emission data
- Capable of detecting change in single transistors
  - Degradation or change of state induced by software (bit change from zero to one)





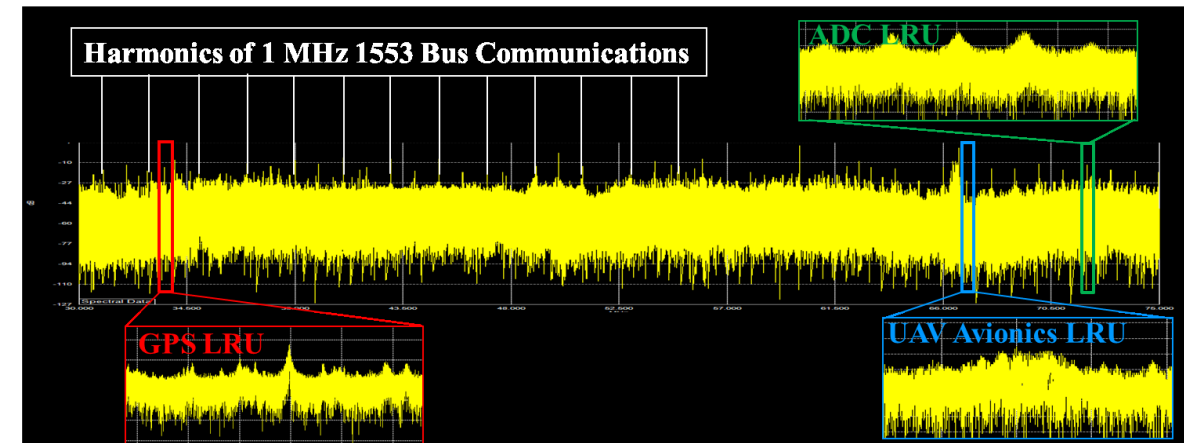
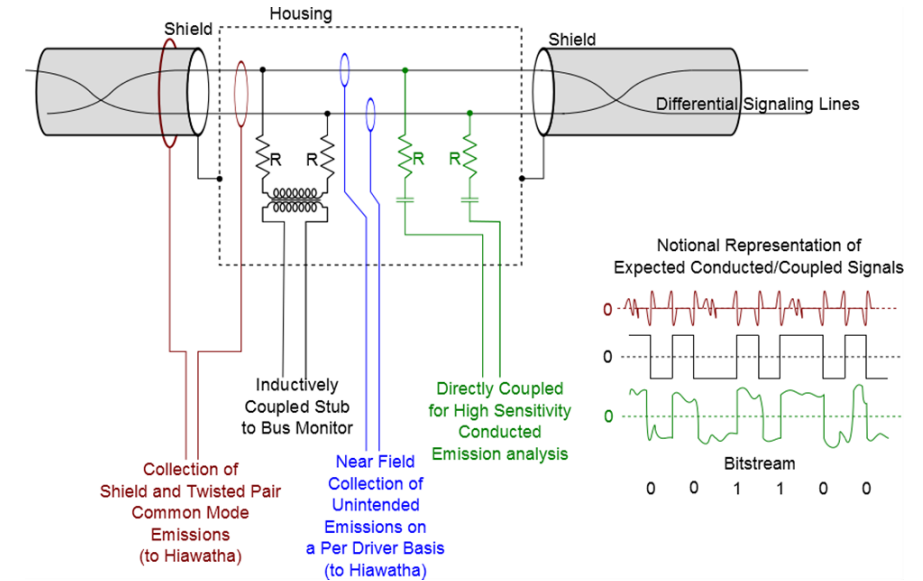
# In-Situ Monitoring: Integration

- In-situ monitoring possible due to miniaturization of multi channel, high acuity RF sensor
- Integration steps shown at right
  - 5''X9''X14'' 20 lb box (1st generation)
  - 3''X9'' Circuit Card Assembly (2nd generation)
  - 8mmX8mm Semiconductor die
- More capability added at each level of integration
- Sensor can be added to system at multiple levels:
  - As a discrete component on CCA to monitor system “health”
  - As embedded IP on a semiconductor die, to monitor other embedded IP (e.g. the Flash Memory on a microcontroller chip)



# Additional Application: Cyber Threat Detection

- Monitoring capability can be extended beyond quantification of degradative effects
- Custom hardware built for high acuity acquisition of conducted RF emissions on data bus
- Successfully utilized to detect signature changes caused by the execution of cyber attacks on hardware connected to data bus



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# Conclusions

- **Traditional reliability estimations are imprecise and error-prone**
  - Arrhenius terms ( $E_A$  and  $n$ ) are not well defined...can cause gross over estimation of component lifetime
  - The link between the equations and physically meaningful or measurable device parameters is weak.
  - May be acceptable for portions the commercial sector
  - Not acceptable for mission or safety-critical applications
  - Not easy to assess remaining component lifetime or actual state of degradation using these methods
  
- **EM Signature Analysis Methodology is Highly scalable and easily integrated**
  - Ideal for in-situ, real-time monitoring of passive and active electronics at a variety of levels (CCA, Individual component, on-die IP)
  - Allow for more precise reliability/degradative state estimates, even when used with a few metrics
  - Monitoring can be extended to include real-time threat detection



# *For Additional Information*



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